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Serial No.: (not yet assigned)

## List of Documents

Cited by Applicant

(Use several sheets if necessary)

Applicant: Eric GERRITSEN, et al.

Filing Date: HEREWITH

Group: (not yet assigned)

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## U.S. PATENT DOCUMENTS

Ex'rs	Document Number	Date	Name	Class	Sub-class	Filing Date, if applicable
AA1	5,545,574	8/13/96	CHEN et al.			
AA2	5,659,194	8/19/97	IWAMATSU et al.			
AA3	4,821,085	4/1989	Haken et al.			
AA4	4,849,802	7/1989	Jackson et al.			

## FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub-class	Transl'n Yes/No
AA5	0 746 012 A2	12/4/96	Europe		
AA6	0123456 A2	01/2000	Europe		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AA7	European Patent Abstract of Japanese Publication No. 05218069, published on August 27, 1993
AA8	"Advances in the formation of C54-TiSi2 with an interposed refractory metal layer: some properties", Microelectronic Engineering, vol. 37-38, November 1997, pages 449-454.
AA9	"Resistivity and morphology of TiSi2 formed on Xe+ implanted polycrystalline silicon", Applied Physics Letters, vol. 56, no. 5 January 12, 1990, pages 440-442.
AB1	European Search Report dated December 3, 1998 with annex on French Application No. 9803134.

Examiner:

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.